High precision measurement of the vacuum box of the PANDA Luminosity detector at FAIR

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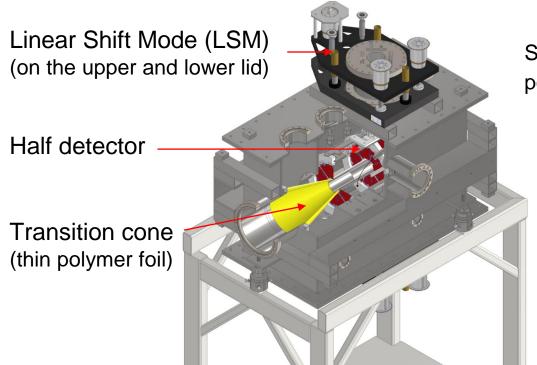
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Lumi-Box





Survey Group delivers position of SMR nests





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But we need position of MuPix



Need of transfer measurement (outside to inside)

Position of half detectors in the box



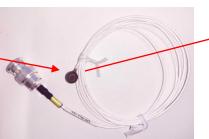
Capacitive distance sensors will measure the position of the half detectors relative to their own position

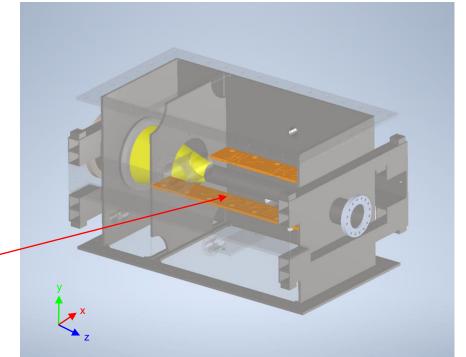
Position of the MuPix sensors relative to the capacitive sensors

Necessary because of the LSM

Cap. sensor with BNC-interface

Estimated Precision: ≤ 1 µm





Plan for transfer measurement



5

Measure box when

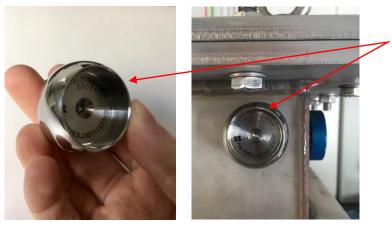
- 1. open
 - Serves as a reference
- 2. partially closed
 - Reveals in what extend box deforms when lower lid is screwed to box body
- 3. completely closed
 - Reveals in what extend box deforms when both lids are screwed to box body
 - Measure how reproductive upper lid can be attached to box body
- 4. vacuum is applied
 - \circ $\,$ Reveals how much box body and lid deform

Transfer measurement



Q: Where are the capacitive sensors inside the box?

A: Measurement arm measures positions of cap. sensors relative to the SMR Ball probe centers



Reset ball makes SMR ball probe center measureable for the arm

Prober for tactile measurement

Manufacturer guarantees precision up to 28 µm (≈ 16 µm in each coord.)

Setup



Arm screwed on cantilever that is attached to box stand

Goal: Measure position of fixed points with a reproduction precision of

$$\sigma=\sqrt{x^2+y^2+z^2}\leq 50 \mu m$$

(≈ 16 µm in each direction)



Method



Problem: Probe tip needs *stable hold* for every point on the box

Solution:

127 washer stacks glued on the box for probing (+27 on the lid)





Reference Measurement – Box without lids

Step 1: Creation of a measurement routine in dedicated software (PC-DMIS)

Step 2: Perform routine 20 times in order to obtain some statistics

Now we have measured each point 20 times

Step 3: Calculate the mean value of and std. dev. for every single point



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Q

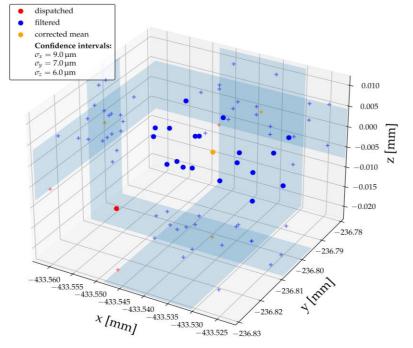
Preliminary Results 1/2



- The measurements cluster around the mean value
- Some measurements can heavily deviate from the mean value (measured in a different angle, etc.)
 - One needs to measure multiple times Dispatch the one with the highest deviation

	Reff LS	Reff RS	Reff lid
$ar{\sigma}_x$	6 µm	19 µm	16 µm
$ar{\sigma}_y$	19 µm	20 µm	19µm
$ar{\sigma}_z$	7 µm	13 µm	16µm

Refference Measurement LS - Reset Ball_BS_1



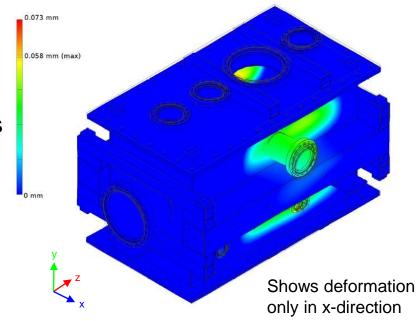
What can we expect under vacuum conditions?

Q: What about vacuum conditions?

A: Box will deform (FEM simulations)

Consequence: Position of capacitive sensors is lost

Solution: Measure how box deforms under vacuum conditions



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Preliminary so far 2/2



Box Deformation - Cycle 1 LS 0.073 mm 120 RS 0.058 mm (max) 100 Deformation in *x*-direction [µm] 100 80 50 y [mm] 60 -500 mm -100-40beam $\begin{array}{c} -\frac{-201}{-300}, \\ -\frac{-500}{-600}, \\ -\frac{-700}{-800}, \\ -8000, \\ -8000, \\ -8000, \\ -8000, \\ -8000, \\ -800$ 20 -1000 100 200 300 400 500 *x* [mm]

Summary and Outlook



- Proof of concept: Measurement arm offers the required resolution
- Results proof that the box design fulfills requirements (rigidity)
- Transfer algorithm: How can the position of the cap. sensors be determined when vacuum is applied?